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Attorney Docket No.: 0492611-0545/MIT-9277CONII

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Seleznev, *et al.* Examiner: Cooke

Serial No.: 10/799,388 Art Unit: 1754

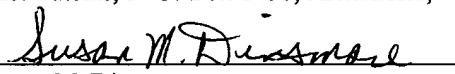
Filing Date: March 12, 2004

Title: VACUUM PROCESSING FOR FABRICATION OF
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-
ORGANIC PROCESSING

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450
Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on May 16, 2005.


Susan M. Dinsmore

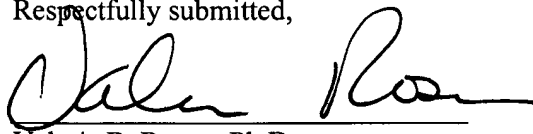
TRANSMITTAL

Enclosed herewith please find:

- 1) Office Action Response Under 37 C.F.R. §1.111 (8 pgs.);
- 2) Terminal Disclaimer Under 37 C.F.R. §1.321 (2 pgs.);
- 3) Declaration Under 37 C.F.R. §1.131, including Exhibit 1 (8 pgs.);
- 4) Declaration Under 37 C.F.R. §1.132, including Exhibits A and B (5 pgs.);
- 5) Check in the amount of \$130.00 for the Terminal Disclaimer fee;
- 6) Return postcard.

Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

Respectfully submitted,


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Dated: May 16, 2005